

PATENT

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

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10/032687



Applicants:

Kim et al.

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For: METHOD FOR FORMING WIRING  
IN SEMICONDUCTOR DEVICES

Attorney Docket No.: 29936/38063

Group Art Unit: to be determined

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
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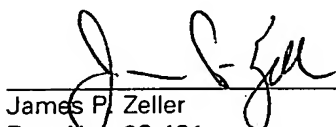
Sir:

The patents and/or publications listed on the enclosed PTO Form-1449 are submitted pursuant to 37 CFR §§ 1.56, 1.97, and 1.98. Copies of the patents or publications are enclosed as necessary.

Respectfully submitted,

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